

Benchmark Tests for MOSFET Compact Models With Application to the PSP Model

Xin Li, Weimin Wu, *Member, IEEE*, Amit Jha, Gennady Gildenblat, *Senior Member, IEEE*,
Ronald van Langevelde, *Member, IEEE*, Geert D. J. Smit, Andries J. Scholten, Dirk B. M. Klaassen, *Member, IEEE*,
Colin C. McAndrew, *Fellow, IEEE*, Josef Watts, C. Michael Olsen, Geoffrey J. Coram, *Member, IEEE*,
Samir Chaudhry, and James Victory

Abstract—This paper presents the results of several qualitative “benchmark” tests that were used to verify the physical behavior of the PSP model and its usefulness for future generations of CMOS IC design. These include newly developed tests and new experimental data stemming from low-power, RF, mixed-signal, and analog applications of MOSFETs.

Index Terms—Benchmark tests, compact model, MOSFET, surface-potential-based model.

I. INTRODUCTION

COMPACT MOSFET models should both provide an accurate reproduction of the minute details of transistor behavior (e.g., higher order transconductances) and be computationally efficient. The latter inevitably requires the use of empirical relations or approximations. By using the surface-potential-based approach to compact modeling [1], the physics content of a compact MOSFET model significantly increases, but the use of semiempirical relations cannot be completely eliminated. It is therefore necessary to prevent unphysical behavior of a compact model, which can occur as an unintended consequence of the use of empirical relations or approximations [2]. Over the years, two techniques have proven to be particularly useful for assuring the high quality of compact models. The principle of asymptotic correctness [3] essentially states that even empirical equations should become exact in extreme

cases. This concept has been extensively used in the development and formulation of PSP. In addition, several “benchmark tests” have been formulated to address those aspects of the qualitative behavior of compact models that are of particular interest to circuit designers [4]–[6]. In this paper, we demonstrate that the new industry standard PSP model satisfies the traditional tests [4]–[6], and we introduce several new tests that verify that PSP meets the stringent requirements imposed on compact models by the continued scaling of MOS devices and their widespread use in RF applications. In this paper, we concentrate on dc and ac tests.

Benchmarking of PSP has been already reported in [7]. In the present investigation, we include additional theoretical results for the traditional tests, analysis of the relation between the singularity at $V_{ds} = 0$ and harmonic balance simulation results, and some results for benchmarking of the PSP-SOI model. We also expand the investigation of the nonreciprocity of transcapacitances at $V_{ds} = 0$ as it relates to the charge-sheet approximation.

The qualitative behavior of PSP does not depend on parameter values. The only exception concerns the strict requirement of the existence of the fifth derivative at $V_{ds} = 0$ that is discussed in Section III-B. For this reason, and to make the results of this work easily reproducible, we have used default parameters in most simulations. However, for the experimental verification of high-order derivatives at $V_{ds} = 0$, we have used PSP parameters for the Jazz Semiconductor 0.18- μm process (cf. Section II-D).

II. TRADITIONAL BENCHMARK TESTS

Among the most important traditional benchmark tests are the slope-ratio (Fig. 1) and tree-top tests (Fig. 4), which evaluate the subthreshold V_{ds} behavior and the g_m/I_d ratio behavior of a model, respectively [6]. These tests essentially require the qualitative behavior of a model to be similar to that of the Pao-Sah [8] or charge-sheet model [9]. Since PSP is a direct descendant of these models, it easily passes both tests for all model parameter values.

A. Slope-Ratio Test

The purpose of the slope-ratio test is to confirm that a MOSFET model can distinguish the qualitative difference in $I_{ds}(V_{ds})$ behavior between subthreshold and strong inversion

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X. Li, W. Wu, and G. Gildenblat are with the Arizona State University, Tempe, AZ 85287 USA (e-mail: xinli@asu.edu; gennady.gildenblat@asu.edu).

A. Jha is with Maxim Integrated Products, Sunnyvale, CA 94086 USA.

R. van Langevelde is with Philips Research Laboratories, 5656 AE Eindhoven, The Netherlands.

G. D. J. Smit, A. J. Scholten, and D. B. M. Klaassen are with NXP Research, 5656 AE Eindhoven, The Netherlands.

C. C. McAndrew is with Freescale Semiconductor, Tempe, AZ 85284 USA.

J. Watts is with the IBM Semiconductor Research and Development Center, System and Technology Group, Essex Junction, VT 05452 USA.

C. M. Olsen is with the IBM Semiconductor Research and Development Center, Hopewell Junction, NY 12533 USA.

G. J. Coram is with the Analog Devices, Inc., Wilmington, MA 01887 USA.

S. Chaudhry is with Jazz Semiconductor, Newport Beach, CA 92660 USA.

J. Victory is with Sentinel IC Technologies, Irvine, CA 92618 USA.

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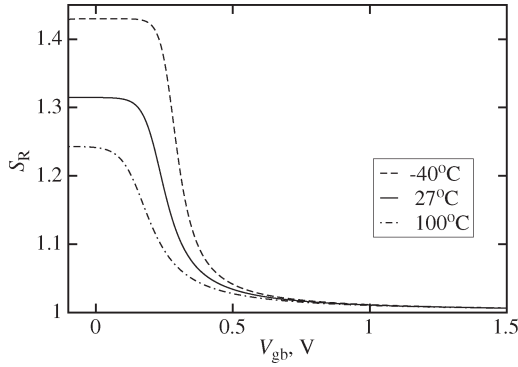


Fig. 1. Traditional slope-ratio test results for PSP using default parameters with $W/L = 10/10 \mu\text{m}$ for different temperatures; $V_{db1} = 10 \text{ mV}$, $V_{db2} = 20 \text{ mV}$, and $V_{sb} = 0$.

operation. This is verified by the reduction of the slope ratio from about 1.3 to 1 with the increase of the gate bias.

The slope ratio is defined as

$$S_R = \frac{(I_2 + I_1)(V_{db2} - V_{db1})}{(I_2 - I_1)(V_{db2} + V_{db1})} \quad (1)$$

where I_1 and I_2 are the drain currents corresponding to $V_{db} = V_{db1}$ and $V_{db} = V_{db2}$, respectively. Fig. 1 shows that PSP passes the test with commonly used $V_{db1} = 0.01 \text{ V}$ and $V_{db2} = 0.02 \text{ V}$. The traditional version of the slope-ratio test (1) suffers from a temperature dependence of the limiting value S_{RO} of S_R in subthreshold region (see Fig. 1). Indeed, the subthreshold current can be expressed as [8]

$$I_d = \mu \frac{W}{L} C_{ox} \cdot \frac{\gamma \phi_t^2}{2\sqrt{\phi_{ss}}} e^{(\phi_{ss} - 2\phi_B - V_{sb})/\phi_t} (1 - e^{-V_{ds}/\phi_t}) \quad (2)$$

where μ is the mobility, C_{ox} is the oxide capacitance per unit area, γ is the body effect factor, ϕ_{ss} is the surface potential at the source end of the channel, ϕ_B is the ‘‘Fermi potential,’’ and $\phi_t = k_B T/q$ is the ‘‘thermal potential.’’ Then

$$S_{RO} = \frac{e^{\beta V} - \cosh(\beta \Delta V)}{\sinh(\beta \Delta V)} \cdot \frac{\Delta V}{V} \quad (3)$$

where

$$\beta = 1/\phi_t \quad (4)$$

$$V = \frac{V_{db1} + V_{db2}}{2} \quad (5)$$

$$\Delta V = \frac{V_{db2} - V_{db1}}{2}. \quad (6)$$

As long as V_{db1} and V_{db2} are fixed (i.e., temperature independent), βV and $\beta \Delta V$ depend on temperature, producing the results shown in Fig. 1. In addition to the S_{RO} temperature dependence, it is not clear what the correct (or ideal) value of S_{RO} is, even at room temperature. To remedy this problem, we select

$$V_{db1} = \frac{\phi_t}{2} - \Delta V \quad (7)$$

$$V_{db2} = \frac{\phi_t}{2} + \Delta V \quad (8)$$

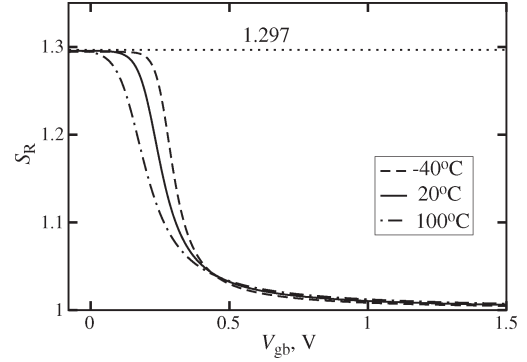


Fig. 2. Modified temperature-independent slope-ratio test results for PSP with default parameters; $\Delta V = 1 \text{ mV}$.

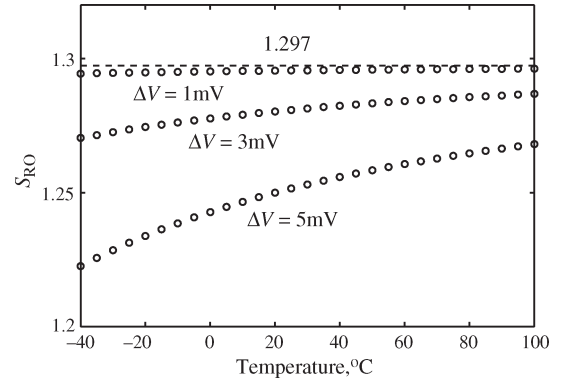


Fig. 3. Sensitivity of S_{RO} to ΔV for PSP.

where $\Delta V \ll \phi_t$. Then, $V_{db1} + V_{db2} = \phi_t$, and from (3)

$$S_{RO} = 2(\sqrt{e} - 1) \approx 1.297 \quad (9)$$

regardless of the temperature. Typical results for PSP are shown in Fig. 2 for $\Delta V = 1 \text{ mV}$, while the sensitivity of S_{RO} to the magnitude of ΔV is shown in Fig. 3. Just as for the original version, the proposed modification of the slope-ratio test checks the conformance of a compact MOSFET model to the classical behavior (2) in the subthreshold region and is applicable to any model.

B. Tree-Top Test

The purpose of the tree-top test is to assure that the details of g_m/I_d ratio bias dependence relevant to the analog design are accurately reproduced by a MOSFET model. For the tree-top test (cf. Fig. 4), note that, in the subthreshold region from (2)

$$\frac{g_m}{I_d} = \left(\beta - \frac{1}{2\phi_{ss}} \right) \frac{\partial \phi_{ss}}{\partial V_{gs}} \quad (10)$$

or, equivalently

$$\frac{g_m}{I_d} = \left(\beta - \frac{1}{2\phi_{ss}} \right) \left(1 - \frac{C_{gg}}{C_{ox}} \right) \quad (11)$$

where β is defined in (4). The increase of the g_m/I_d ratio with gate bias follows the corresponding decrease of C_{gg} . Note also that, as shown in Fig. 4, this ratio never actually reaches

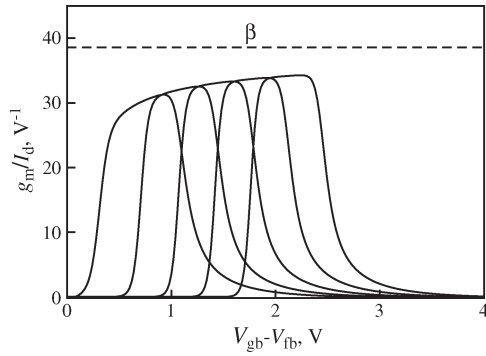


Fig. 4. Tree-top test results for PSP using default parameters with $V_{ds} = 50$ mV, V_{bs} varies from -1 to 0.2 V in 0.3 -V steps, $V_{fb} = -1$ V, $W/L = 10/10$ μm , and $T = 27$ $^\circ\text{C}$. Horizontal line represents $\beta = 38.6$ V^{-1} .

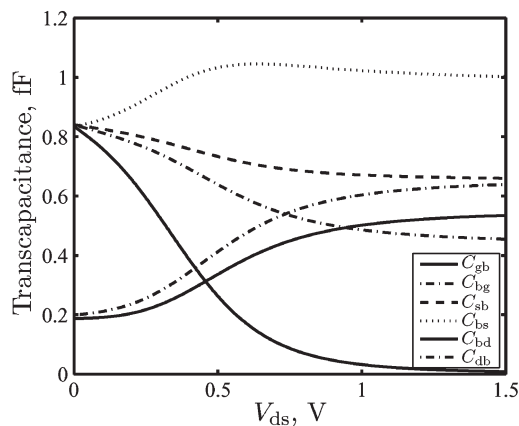


Fig. 5. Transcapacitances for PSP with $W/L = 10/0.08$ μm and $V_{gs} = 1.2$ V.

its theoretical maximum value β since $C_{gg} > 0$. In simpler threshold-voltage-based models, the subthreshold region is often described using the semiempirical relation

$$I_d \propto \exp\left(\frac{V_{gb} - V_t}{n\phi_t}\right) \quad (12)$$

where V_t denotes the threshold voltage, and n is a fixed constant. In this approach

$$\frac{g_m}{I_d} = \frac{\beta}{n} \quad (13)$$

is constant in the subthreshold region, and the effect of the variation of C_{gg} with V_{gb} is lost.

C. Transcapacitances

Transcapacitances as functions of the terminal bias with fine resolution are traditionally investigated to detect possible singular behavior. Fig. 5 shows the typical results that verify the continuous and physical behavior of the transcapacitances of PSP, including the correct sign for C_{bd} and C_{gb} . The latter is problematic in some older models that separate charge and current submodels, but in PSP, the symmetric linearization technique [1] provides consistency of both submodels with the desired behavior seen in Fig. 5.

D. GST

The design of certain circuits, most importantly of passive RF mixers and transfer gates, requires symmetry of a MOSFET model with respect to source–drain terminal interchange [10]. The typical results for PSP are presented as solid lines in Fig. 6, indicating that PSP passes this test. As in [6], V_b denotes the body bias, $V_x = V_{ds}/2$, and $V_{bo} = (V_{db} + V_{sb})/2$. Three necessary conditions for this include a nonsingular velocity saturation model [1], [10], an odd smoothing function describing the transition from the triode to the saturation region of the MOSFET characteristics [1], [11], and the symmetry of the linearization procedure for the inversion and bulk charges as functions of the surface potential [1]. The aforementioned discussion refers exclusively to the qualitative behavior of the drain current and its derivatives for $V_{ds} = 0$ (i.e., for $V_X = 0$ in terms of the Gummel symmetry test (GST) setup as in [6]). The results shown in Fig. 6 demonstrate that PSP accurately reproduces the actual test data (symbols). Note that this is the first ever experimental investigation of the higher order derivatives for a MOS transistor operated at zero drain bias and that, only a short time ago, it was impossible to model even the second derivative for $V_X = 0$ with the industry standard MOSFET model.

III. NEW TESTS

A. Subthreshold Region

The purpose of the new test is essentially the same as that of the slope-ratio test—to verify the characteristics of $I_d(V_{ds})$ dependence predicted by (2). The difference is that, instead of the somewhat unintuitive concept of a slope ratio, the test is formulated in terms of output conductance, which is more relevant to both model parameter extraction and design applications. In terms of the output conductance $g_{ds} = \partial I_d / \partial V_d$, we find from (2) that

$$(\partial/\partial V_d) [g_{ds} \cdot \exp(V_{ds}/\phi_t)] = 0 \quad (14)$$

implying zero slope for $g_{ds} \cdot \exp(V_{ds}/\phi_t)$ versus V_{ds} plots. This is indeed observed in subthreshold operation, while increasing the gate bias leads to the formation of an inversion layer and, consequently, to a finite slope (see Fig. 7). There is an interesting connection between this characteristic behavior and the GST. It is common knowledge that, when velocity saturation is directly included into the charge-sheet MOSFET model, it gives an unacceptable negative g_{ds} in the saturation region. This problem is usually solved via the use of certain smoothing functions to model the transition from triode to saturation region operation by changing V_{ds} into an effective drain bias V_{dse} [1]. To pass the GST, the $V_{dse}(V_{ds})$ function has to be odd [11] with an additional requirement of unity slope at $V_{ds} = 0$ suggested in [12]. In fact, this latter condition is not required for passing the GST but is useful to ensure that (14) is satisfied. More precisely, one needs to require approximately a unity slope of dV_{dse}/dV_{ds} for $V_{ds} < 3\phi_t$. If this condition is violated, so is (14), as shown in Fig. 8.

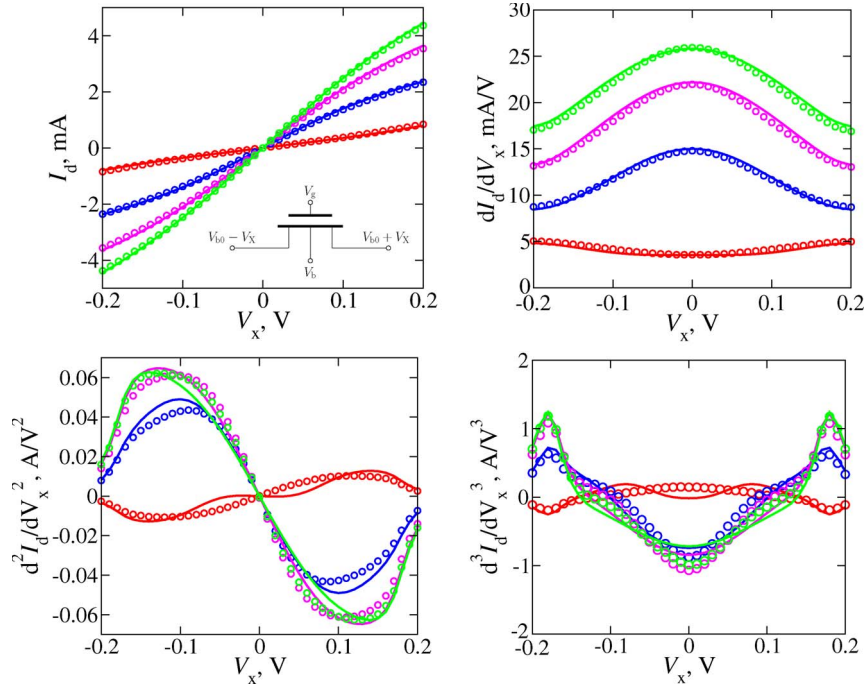


Fig. 6. Drain current and derivatives for Jazz Semiconductor 0.18- μm technology n-channel 10/0.18 μm MOSFET; V_g varies from 0.6 to 1.8 V in steps of 0.4 V. Symbols represent experimental data, while solid lines refer to PSP; $V_b = 0$ V; and $V_{b0} = 0$ V. Inset shows the circuit diagram for simulation.

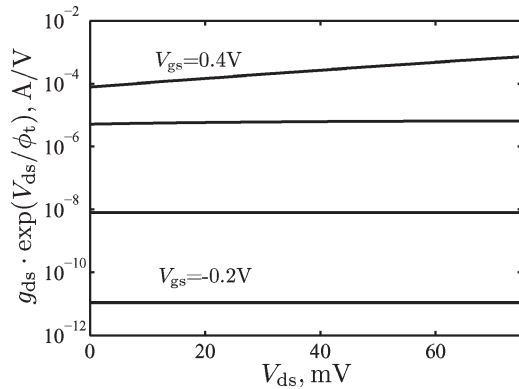


Fig. 7. PSP results for subthreshold region; V_{gs} varies from -0.2 to 0.4 V in 0.2 -V steps. Default parameters are used.

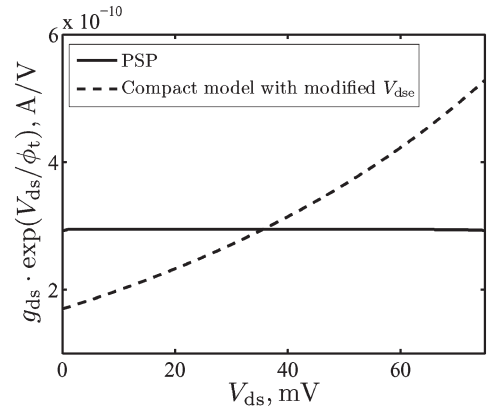


Fig. 8. Comparison of PSP and another compact model with modified V_{dse} for which dV_{dse}/dV_{ds} differs from one appreciably for $V_{ds} < 3\phi_t$; $V_{gs} = -0.1$ V.

B. Higher Order Derivatives in the GST

To model harmonic distortion in RF circuits operating with zero drain–source dc bias, it is now deemed necessary for compact models to be not just class $C^{(3)}$ (derivatives continuous to third order) but, at least, class $C^{(5)}$. The nature of the smoothing function

$$V_{dse} = \frac{V_{ds}}{\left[1 + \left(\frac{|V_{ds}|}{V_{dsat}}\right)^{\mathbf{AX}}\right]^{\frac{1}{\mathbf{AX}}}} \quad (15)$$

used in PSP is such that class $C^{(3)}$ behavior is automatically guaranteed ($\mathbf{AX} > 2$), but in order for the n th derivative to exist at $V_{ds} = 0$, it is necessary to impose the condition

$$\mathbf{AX} > n - 1. \quad (16)$$

One exception to this requirement is when \mathbf{AX} is an even integer in which case the derivatives of all orders exist.

The local parameter \mathbf{AX} scales with the device effective channel length L as

$$\frac{\mathbf{AXO}}{1 + \mathbf{AXL}/L} \quad (17)$$

where \mathbf{AXL} is a global (scaling) parameter. For short-channel devices, this limits the range of \mathbf{AXL} , making it more difficult to cfit g_{ds} as a function of drain bias. Typical results for $n = 5$ for different values of \mathbf{AX} are shown in Fig. 9. This limitation is not specific to PSP, and in fact, in the previous standard model, the second derivative does not exist for $V_{ds} = 0$ [12].

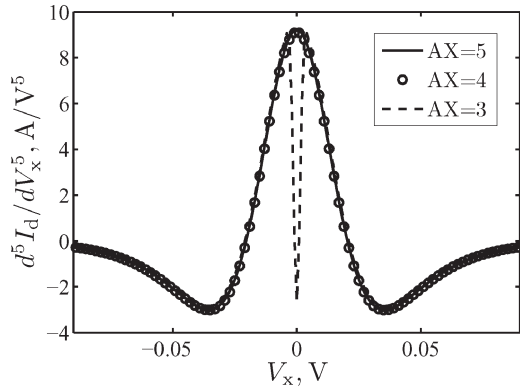


Fig. 9. Fifth order derivatives for different \mathbf{AX} (using the GST biasing scheme). For $\mathbf{AX} = 3$, condition (16) is violated. Apart from \mathbf{AX} , PSP model parameters used are for a 90-nm technology node.

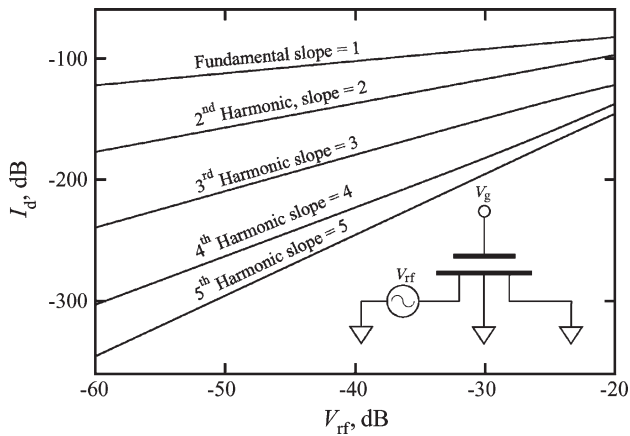


Fig. 10. Single tone harmonic balance simulation result for PSP; $V_g = 0.4$ V, $W/L = 10/0.35$ μm , and fundamental frequency is 100 MHz. Inset shows the circuit diagram for simulation. Default parameters are used for PSP.

C. Modified Symmetry Test

The traditional GST does not apply in the presence of gate and substrate currents. For this reason, a new test has been developed in [13]. Typical results including gate current presented in [13] and [7] show that PSP passes this test. The last reference also contains the results for SOI MOSFET model with the valence-band tunneling current included [16], indicating that PSP-SOI [14] also passes the test.

D. Harmonic Balance Simulation

Distortion analysis is a key to evaluate the performance of RF circuits. Traditional MOSFET models produce unphysical harmonic balance simulation results for the third and higher order harmonics due to their asymmetric behavior around $V_{ds} = 0$ [10], [18]. A detailed analysis of the origin of this unphysical behavior is presented in the Appendix. Theory [15] indicates that the second harmonic should be proportional to the square of the input signal level, the third harmonic should be proportional to the cube of the input signal level, and so on. Fig. 10 shows a single tone harmonic balance simulation result for PSP using the circuit in Fig. 10. PSP produces correct slopes for up to the fifth order harmonic. Harmonic balance simulation with the

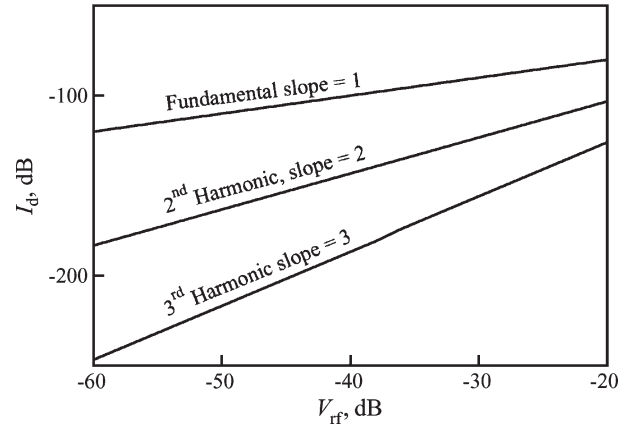


Fig. 11. Single tone harmonic balance simulation results for PSP-SOI; $V_g = 0.5$ V, $W/L = 10/0.5$ μm , and fundamental frequency is 100 MHz. Default parameters are used.

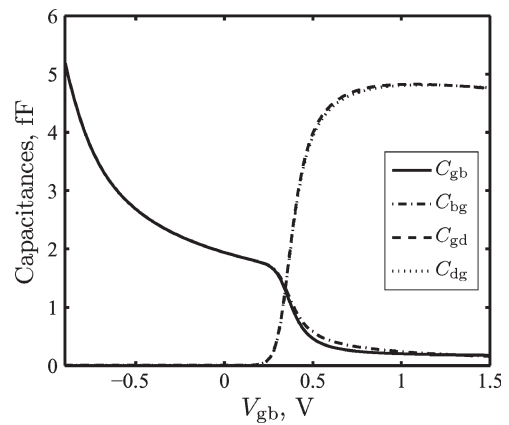


Fig. 12. Transcapacitances C_{gd} , C_{dg} , C_{gb} , and C_{bg} for PSP with $W/L = 10/0.08$ μm at $V_{ds} = 0$. Default parameters are used.

PSP-SOI model [16] using a similar circuit was also performed. The results shown in Fig. 11 verify that PSP-SOI has the same qualitatively correct behavior as PSP.

E. Reciprocity

Generally speaking, MOSFET transcapacitances are non-reciprocal. However, for $V_{ds} = 0$ (a condition often used for model parameter extraction), reciprocity is recovered. In both PSP and one of its predecessors MM11 [17], the reciprocity condition is approximately satisfied for $V_{ds} = 0$ with an accuracy sufficient for engineering applications (Fig. 12). Note that the symmetry of the model assures that, in PSP, $C_{ds} = C_{sd}$ exactly for $V_{ds} = 0$.

The small deviation from reciprocity is associated with the charge-sheet approximation [17]. To demonstrate this explicitly, we compare the results of a charge-sheet model [9] with those of the Pao-Sah model [8]. As Fig. 13 shows, the latter satisfies the reciprocity conditions perfectly, while the charge-sheet model has a small nonreciprocity comparable to that of PSP (see Fig. 12), which also uses the charge-sheet approximation.

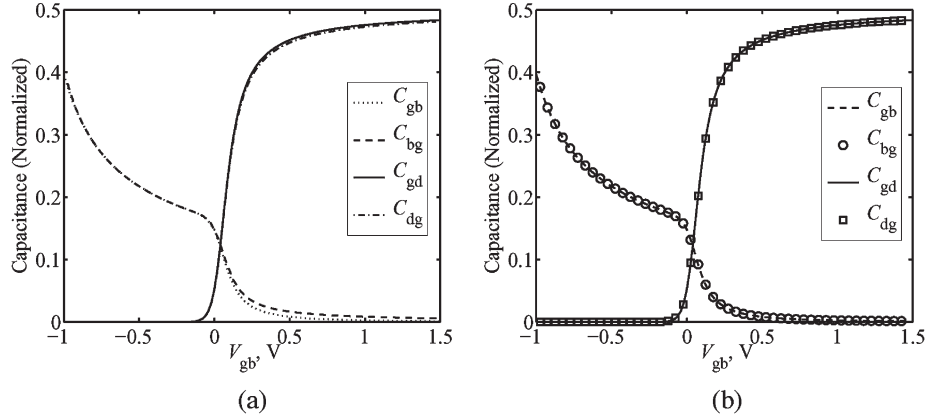


Fig. 13. Transcapacitances C_{gd} , C_{dg} , C_{gb} , and C_{bg} for charge-sheet model [9] and Pao-Sah model [8] at $V_{ds} = 0$, respectively; $t_{ox} = 4$ nm, and $N_a = 3E23 \text{ m}^{-3}$. (a) Charge-sheet model. (b) Pao-Sah model.

IV. CONCLUSION

A battery of traditional, modified, and newly developed benchmark tests is available to MOSFET model developers to evaluate the correct qualitative behavior of compact models. We present the results of the application of these tests to the new industry standard MOSFET model PSP. The experimental data for higher order derivatives of the drain current at $V_{ds} = 0$ are presented for the first time and are accurately reproduced by PSP.

APPENDIX

The origin of the 2 dB/dB slope of the third harmonic characteristics for singular transistor models has been investigated in [18] for a simple MESFET model, keeping second order terms in the analysis. Here, we extend the method of [18] to a more general case and factor in details of how MOSFET models are implemented in circuit simulators.

The implementation of MOSFET models in circuit simulators is such that, regardless of the internal symmetry of a model, the condition

$$I_d = f(V_{sb}, V_{db}, V_{gb}) = -f(V_{db}, V_{sb}, V_{gb}) \quad (18)$$

is imposed. In the case of GST (cf. Fig. 6), V_g and V_{bo} are fixed, and the ‘‘symmetry condition’’ takes the form

$$I_d(-V_X) = -I_d(V_X) \quad (19)$$

where

$$I_d(V_X) = f(-V_{bo} - V_X, -V_{bo} + V_X, V_{gb}). \quad (20)$$

If a compact MOSFET model is inherently symmetric, the imposition of the symmetry condition (18) by the circuit simulator is inconsequential. However, its imposition on asymmetric models produces singularities, usually in the form of the nonexistence of the second derivative $d^2 I_d / dV_X^2$ for $V_X = 0$ (cf. Fig. 14).

To investigate the consequences, consider first the symmetric single tone excitation corresponding to Fig. 6 with $V_{bo} = 0$ and $V_X = (1/2)V_o \cos(\omega t)$. In what follows, $V = 2V_X = V_{ds}$.

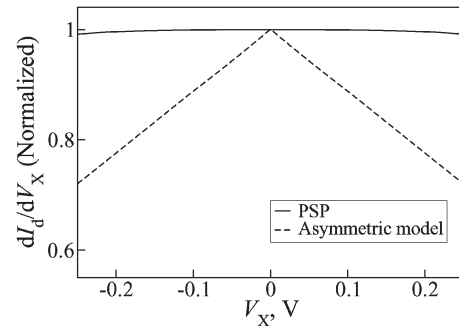


Fig. 14. Illustration of (21) and (25). For PSP $b = 0$, for an asymmetric model, $b = -b' \neq 0$.

Assuming that the $I(V)$ characteristic is such that the first three derivatives exist at $V = 0$

$$I_d = aV + bV^2 + cV^3 + o(V^3) \quad (21)$$

where a , b , and c are constants. For a symmetric model $b = 0$ therefore

$$I_d = I_1 \cos(\omega t) + I_3 \cos(3\omega t) + o(V_o^3) \quad (22)$$

where (cf. Fig. 15)

$$I_1 = aV_o + \frac{3}{4}cV_o^3 \quad (23)$$

$$I_3 = \frac{cV_o^3}{4}. \quad (24)$$

For asymmetric models, instead of (21), one has

$$I_d = \begin{cases} aV + bV^2 + cV^3 + o(V^3), & V \geq 0 \\ aV + b'V^2 + c'V^3 + o(V^3), & V < 0. \end{cases} \quad (25)$$

Here, as in [12] and [18], the first derivative exists and is continuous

$$a = I'(0) \quad (26)$$

$$b = \frac{1}{2} \lim_{V \downarrow 0} I''(V) = \frac{1}{2} I''(0+) \quad (27)$$

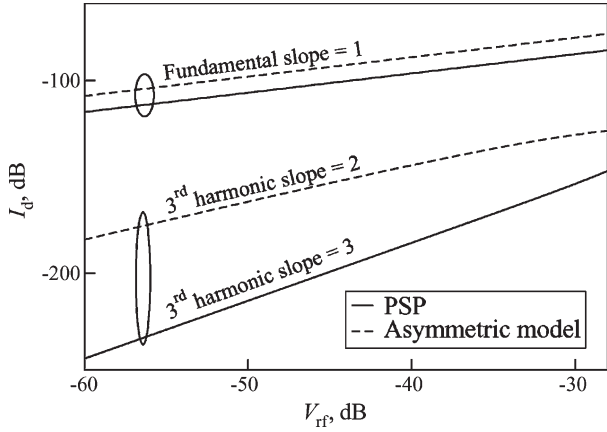


Fig. 15. Harmonic balance simulation results for symmetric excitations; $V_g = 0.4$ V, $W/L = 10/0.35$ μm , and fundamental frequency is 100 MHz. Default parameters are used for PSP.

$$b' = \frac{1}{2} \lim_{V \uparrow 0} I''(V) = \frac{1}{2} I''(0-) \quad (28)$$

$$c = \frac{1}{6} \lim_{V \uparrow 0} I'''(V) = \frac{1}{6} I'''(0+) \quad (29)$$

$$c' = \frac{1}{6} \lim_{V \uparrow 0} I'''(V) = \frac{1}{6} I'''(0-). \quad (30)$$

By (19)

$$b' = -b \quad (31)$$

$$c' = c. \quad (32)$$

In [18], the condition (18) was not imposed, and $c = c' = 0$. Note also that, in engineering practice, it is common to describe the case shown in Fig. 14 as “discontinuity of the second derivative” [18]. However, of course, according to the Darboux theorem, the derivative of the function cannot have discontinuity of the first kind; thus, we deal with the case where the second derivative of $I_d(V)$ does not exist at $V = 0$.¹ Using the symmetry condition (19) once more allows one to expand $I_d(V)$ in a Fourier series in the form (in our case $I_0 = I_2 = 0$)

$$I_d = \frac{I_0}{2} + \sum_{k=1}^{\infty} I_k \cos(k\omega t). \quad (33)$$

The amplitude of the third harmonic is

$$I_3 = \frac{4}{T} \int_0^{T/2} I(t) \cos(3\omega t) dt. \quad (34)$$

Simple computation yields

$$I_3 = \frac{4(b-b')V_o^2}{15\pi} + \frac{cV_o^3}{4} + o(V_o^3) \quad (35)$$

¹More precisely, $(I_d)'_+(0) = I_d''(0+) \neq I_d''(0-) = (I_d)'_-(0)$.

or, with reference to (31)

$$I_3 = \frac{8bV_o^2}{15\pi} + \frac{cV_o^3}{4} + o(V_o^3). \quad (36)$$

Here, the second term is the same as in (24), while the first one is associated with the singularity described by (25) and first studied in [18] for a special case. For small V_o , $I_3 \propto V_o^2$, which explains the slope of 2 dB/dB for the third harmonic observed in harmonic balance tests of some older models (see Fig. 15). Note also that (35) allows one to trace the gradual transition from the regime $I_3 \propto V_o^2$ to that of $I_3 \propto V_o^3$, as $|b-b'| = 2|b|$ is reduced relative to $|c|V_o$.

Returning to a standard asymmetric excitation version of the harmonic balance test shown in Fig. 10, one has (25) with $V = V_{rf} = V_o \cos(\omega t)$ but without the symmetry condition $I_d(-V) = -I_d(V)$ and, hence, with $b' \neq -b$ and, in general, $c' \neq c$. This yields

$$I_3 = \frac{4(b-b')V_o^2}{15\pi} + \frac{(c+c')V_o^3}{8} + o(V_o^3). \quad (37)$$

Once again, the erroneous 2 dB/dB slope appears for the third harmonic, as illustrated in [10].

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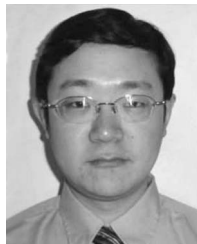
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Gennady Gildenblat (M'83–SM'87) received the Ph.D. degree in solid-state physics from Rensselaer Polytechnic Institute, Troy, NY, in 1984.

In 1980, he was with the General Electric Corporate Research and Development Center, Schenectady, NY, where he was engaged in various aspects of semiconductor device physics and IC technology development. Between 1984 and 1986, he supervised the cryogenic CMOS device engineering study with the Digital Equipment Corporation, Hudson, MA. From 1986 to 2006, he was a Professor of electrical engineering with the Pennsylvania State University, University Park. Since 2006, he has been with the Arizona State University, Tempe, as the Motorola Professor of electrical engineering. Together with his graduate students, he has developed several advanced surface-potential-based compact MOSFET models. The PSP model (jointly developed with Philips) has been selected as the new international industry standard by the Compact Model Council. His research interests include semiconductor device physics and modeling, novel semiconductor devices, and semiconductor transport. He has over 140 publications in these areas, including several books, invited articles, and U.S. patents.

Dr. Gildenblat is the corecipient of the 2006 Semiconductor Research Corporation Technical Excellence Award. He is currently a member of the technical program committees for IEDM and CICC.



Xin Li received the B.S. degree in electrical engineering from Huazhong University of Science and Technology, Wuhan, China, in 2001 and the M.S. degree in electrical engineering from The Pennsylvania State University, University Park, in 2006. He is currently working toward the Ph.D. degree in electrical engineering at the Arizona State University, Tempe.

His research interests include device compact modeling and statistical modeling.



Ronald van Langevelde (S'94–M'98) received the M.Sc. and Ph.D. degrees in electrical engineering from Eindhoven University of Technology, Eindhoven, The Netherlands, in 1994 and 1998, respectively.

Since 1998, he has been with Philips Research Laboratories, Eindhoven, where he worked on compact MOS models for circuit simulation and is now working on RF CMOS circuit design. He is the Main Developer of MOS Model 11 and a Codeveloper of the PSP MOSFET model.



Weimin Wu (S'03–M'07) received the B.S. degree in physics from the University of Science and Technology of China, Hefei, China, in 1997, the M.S. degree in physics from Rensselaer Polytechnic Institute, Troy, NY, in 2003, and the Ph.D. degree in electrical engineering from the Arizona State University, Tempe, in 2007.

He is currently an Assistant Professor Research of electrical engineering with the Arizona State University. His research interests include semiconductor device and physics, mainly focusing on

CMOS/SOI device compact modeling.

Dr. Wu is the corecipient of the 2006 Semiconductor Research Corporation Technical Excellence Award.



Geert D. J. Smit received the M.Sc. degrees in experimental physics and in mathematics from the University of Utrecht, Utrecht, The Netherlands, in 1998 and 1999, respectively, and the Ph.D. degree in experimental physics from Delft University of Technology, Delft, The Netherlands, in 2004.

Since 2004, he has been with Philips Research Laboratories and NXP Research, Eindhoven, The Netherlands, where he is working on compact MOSFET models.



Amit Jha received the B.Tech. degree from the Indian Institute of Technology, Madras, India, in 2004 and the M.S. degree from the Pennsylvania State University, University Park, in 2007.

He is currently with Maxim Integrated Products, Sunnyvale, CA, as an Analog Design Engineer with focus on creating fast and efficient macromodels for analog blocks. From December 2003 to May 2004, he was an Exchange Research Student at the Institut National des Sciences Appliquées de Lyon, Villeurbanne, France. His research interests are

analog design and device modeling.



Andries J. Scholten received the M.S. and Ph.D. degrees in experimental physics from the University of Utrecht, Utrecht, The Netherlands, in 1991 and 1995, respectively.

Since 1996, he has been with Philips Research Laboratories and NXP Research, Eindhoven, The Netherlands, where he works on compact MOS models for circuit simulation.



Dirk B. M. Klaassen (M'01) received the Ph.D. degree in experimental physics from the Catholic University of Nijmegen, Nijmegen, The Netherlands, in 1982.

He then joined Philips Research Laboratories, Eindhoven, The Netherlands, where he worked on various subjects in the field of luminescence from the solid state and modeling for silicon device simulation, most notably the Philips Unified Mobility Model. In the early 1990s, he switched to compact modeling for circuit simulation. He is currently with

NXP Research, Eindhoven, where he is an NXP Research Fellow. He has codeveloped and industrialized well-known compact models such as Mextram, MOS Model 9, and MOS Model 11. He is the holder of several patents and has authored or coauthored over 80 papers in scientific journals and conferences.

Dr. Klaassen was the Short-Course Chair of the 1999 International Electron Devices Meeting.



Colin C. McAndrew (S'82–M'84–SM'90–F'04) received the Ph.D. degree in systems design engineering from the University of Waterloo, Waterloo, ON, Canada, in 1984.

From 1987 to 1995, he was with AT&T Bell Laboratories, Allentown, PA. Since 1995, he has been with Freescale Semiconductor (formerly Motorola), Tempe, AZ.

Dr. McAndrew received the Best Paper Awards for ICMTS in 1993 and CICC in 2002, the BCTM Award in 2005, and the SRC Mahboob Khan Outstanding Mentor Award in 2007 and was the Vice-Chairman of the Compact Model Council from 2004 to 2007. He is an Editor of the IEEE TRANSACTIONS ON ELECTRON DEVICES, and is or has been on the technical program committees for the IEEE BCTM, ICMTS, CICC, and BMAS conferences.

Dr. McAndrew received the Best Paper Awards for ICMTS in 1993 and CICC in 2002, the BCTM Award in 2005, and the SRC Mahboob Khan Outstanding Mentor Award in 2007 and was the Vice-Chairman of the Compact Model Council from 2004 to 2007. He is an Editor of the IEEE TRANSACTIONS ON ELECTRON DEVICES, and is or has been on the technical program committees for the IEEE BCTM, ICMTS, CICC, and BMAS conferences.

Josef Watts, photograph and biography not available at the time of publication.



C. Michael Olsen received the M.S. degree in electrical engineering from the Technical University of Denmark, Lyngby, Denmark, in 1986 and the Industrial Ph.D. degree from the Danish Academy of Technical Sciences, Lyngby, in 1990. His thesis work was on optical communication systems.

He is currently a Senior Engineer with IBM Semiconductor Research and Development Center, Hopewell Junction, NY, developing models and investigating distortion in RF-CMOS devices. Prior to this, he has worked on processor power management,

Windows/Linux system programming, Java applications, wireless MAC protocols, and optical computer interconnects.



Geoffrey J. Coram (S'97–M'00) received the B.A. degree (*cum laude*) in physics and mathematics and the Master of electrical engineering degree from Rice University, Houston, TX, in 1993 and the Ph.D. degree in electrical engineering from the Massachusetts Institute of Technology, Cambridge, in 2000 with a thesis on thermodynamics and noise modeling in circuits.

Since 2000, he has been with Analog Devices, Inc., Wilmington, MA, working on their internal circuit simulator. In 2004, he led the Accellera Verilog-

AMS subcommittee's work in adding compact modeling extensions to that modeling language.



Samir Chaudhry received the M.S. and Ph.D. degrees in electrical engineering from the University of Florida, Gainesville, in 1993 and 1996, respectively.

From 1996 to 2002, he was with Agere Systems (formerly Bell Labs, Lucent Technologies), working on process and device modeling. Since 2003, he has been with Jazz Semiconductor, Newport Beach, CA. He has authored or coauthored over 20 publications in peer-reviewed journals and conferences and is the holder of 14 patents in the field of silicon technology. His research interests include RF CMOS and statistical modeling.

AMS subcommittee's work in adding compact modeling extensions to that modeling language.



James Victory received the B.S., M.S., and Ph.D. degrees in electrical engineering from the Arizona State University, Tempe, in 1990, 1992, and 1994, respectively.

In June 2008, he cofounded Sentinel IC Technologies, Irvine, CA, to develop and deliver innovative design enablement solutions to the greater semiconductor design and manufacturing industry. Prior to founding Sentinel, he was with semiconductor foundry Jazz Semiconductor from 2003, where he held positions from Modeling Manager to Executive Director of IC Design Enablement. From 2001 to 2003, he was with ultrawideband (UWB) startup XtremeSpectrum, where he was the Director of Semiconductor Technology and a Key Contributor to the industry first UWB chipsets. He held positions in the semiconductor product sector of Motorola from 1992 to 2001. In 1997, he managed the ramp-up of an RF semiconductor characterization and modeling lab for Motorola's European IC Design Center, Geneva, Switzerland. From 1992 to 1997, he reached the status of Principal Member of the Technical Staff, specializing in semiconductor device modeling for circuit simulation of RF analog and power technologies. He has over 30 publications, including invited papers & workshop tutorials on semiconductor device modeling and design enablement for power and RF applications.

AMS subcommittee's work in adding compact modeling extensions to that modeling language.